



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit: 2882

Application No.: 10/589,962

Examiner: C. RIDDLE

Filed: August 18, 2006

Docket No.: 128675

For: EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND
DEVICE MANUFACTURING METHOD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the January 13, 2010 Office Action, the period for response being extended
by the attached Petition for Extension of Time and in view of the June 8, 2010 personal
interview, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.